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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Yasuhiro TAKAKI

U.S. Application No.: 10/582,101

Filed: June 8, 2006

Group: Unassigned

Examiner: Unassigned

For: PATTERN FORMATION METHOD USING NANOIMPRINTING AND DEVICE FOR CARRYING OUT SAME

Commissioner for Patents  
Alexandria, VA 22314

**NOTICE TO FILE CORRECTED PTO FORM-1449**

Upon further review of IDS filed June 8, 2006, Applicants find that the document number USPN 5,947,027 was mistyped. Accordingly, Applicants enclose a corrected PTO Form 1449.

Respectfully submitted,

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Date: August 14, 2006

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**INFORMATION DISCLOSURE CITATION**

(Use several sheets if necessary)

PTO Form 1449

Attorney Docket No.

042715-5020

Serial No.

Unassigned

Applicants

Yasuhiro TAKAKI

Filing Date

June 8, 2006

Group

Unassigned

**U.S. PATENT DOCUMENTS**

*Examiner Initial	Document Number	Date	Name	Class	Sub Class	Filing Date
	US 5,947,027	September 7, 1999	Burgin, et al.			September 8, 1998
	US 5,772,905	June 30, 1998	Chuo			November 15, 1995

**FOREIGN PATENT DOCUMENTS**

	Document Number	Date	Country	Class	Sub Class	Translation	
						YES	NO
	JP-A-2002-158192	May 31, 2002	Japan			abstract	
	JP-A-2003-077807	March 14, 2003	Japan			abstract	
	JP-A-2003-527248	September 16, 2003	Japan			X	
	JP-A-2002-100079	April 5, 2002	Japan			abstract	
	JP-A-2003-516644	May 13, 2003	Japan			X	

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


Examiner

Date Considered

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.